

10/500268

DT04 Rec'd PCT/PTO 23 JUN 2004

92372

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re U.S. Patent Application )  
Applicant: ANDO et al. )  
Serial No.: Unassigned )  
Filed: June 23, 2004 )  
For: METHOD FOR ELIMINATING DEFECTS FROM )  
SINGLE CRYSTAL SILICON, AND SINGLE CRYSTAL )  
SILICON )

**PRELIMINARY AMENDMENT**

Mail Stop PCT  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

Preliminary to the examination of the above application, please amend as follows: